

03560.002760.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Shuichi YABU) Examiner: A. Mathews
Application No.: 09/811,447) Group Art Unit: 2851
Filed: March 20, 2001)
For: EXPOSURE APPARATUS, GAS)
REPLACING METHOD, AND METHOD)
OF MANUFACTURING A)
SEMICONDUCTOR DEVICE) June 24, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Supplemental Preliminary Amendment in the above-identified application.

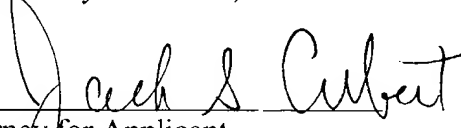
☐ No additional fee is required.

The fee has been calculated as shown below:

| CLAIMS AS AMENDED | | | | | | |
|---|---|-------|---------------------------------------|------------------|----------------|-------------------|
| | CLAIMS REMAINING AFTER AMENDMENT | | HIGHEST NO. PREVIOUSLY PAID FOR | PRESENT EXTRA | RATE | ADDITIONAL FEE |
| TOTAL CLAIMS | 68 | MINUS | 55 | = 13 | x \$9 \$18 | \$ 234.00 |
| INDEP. CLAIMS | 20 | MINUS | 16 | = 4 | x \$42 \$84 | \$ 336.00 |
| Fee for Multiple Dependent claims \$140/\$280 | | | | | | — |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT | | | | | | \$ 570.00 |

- ☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☒ A check in the amount of \$ 570.00 is enclosed for the additional claims fee.
- ☐ Charge \$____ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- ☐ A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.
- ☐ A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicant's attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
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SUPPLEMENTAL PRELIMINARY AMENDMENT

Sir:

07/14/2003 RTYSON 00:00:00 00:00:00

01 FC:1202
02 FC:1201

Prior to further examination on the merits and supplemental to the Preliminary
236.00 OP

Amendment filed May 28, 2003, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled "Amendments in a Revised Format Now Permitted."